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IN THE U.S. PATENT AND TRADEMARK OFFICE

June 1, 2005

Applicants : Takaomi NAKAYAMA et al

For : TREATING SOLUTION FOR SURFACE TREATMENT OF
METAL AND A METHOD FOR SURFACE TREATMENT

PCT International Application No.: PCT/JP2003/015868

PCT International Filing Date: December 11, 2003

U.S. Application No.

(if known, see 37 CFR 1.5): Unknown

Atty. Docket No.: 4626.P0002US

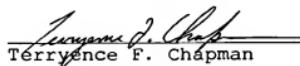
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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(1) and 1.98, enclosed herewith is a copy of the International Search Report, Form PTO-1449 and the Japanese reference cited thereon. The relevance of the references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

Respectfully submitted,


Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL & TANIS, P.C. 2026 Rambling Road Kalamazoo, MI 49008-1631 Phone: (269) 381-1156 Fax: (269) 381-5465	Dale H. Thiel David G. Boutell Ronald J. Tanis Terryence F. Chapman Mark L. Maki Liane L. Churney Brian R. Tumm Steven R. Thiel Donald J. Wallace Sidney B. Williams, Jr.	Reg. No. 24 323 Reg. No. 25 072 Reg. No. 22 724 Reg. No. 32 549 Reg. No. 36 589 Reg. No. 40 694 Reg. No. 36 328 Reg. No. 53 685 Reg. No. 43 977 Reg. No. 24 949
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Encl: Copy of International Search Report
Form PTO-1449 and one copy of Japanese reference

336.05/03

INFORMATION
DISCLOSURE
CITATIONAppl. No.: Takaomi NAKAYAMA et al
Ser. No.: Unknown
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Group: Unknown
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Atty. Docket No.: 40267 P0002US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			
	AG			
	AH			
	AI			
	AJ			
	AK			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
/LZ/	AL	JP 2003-253461	09-10-2003	Yasushi et al	X
	AM				
	AN				
	AO				
	AP				

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	
	AR	

EXAMINER SIGNATURE /Lois Zheng/ DATE CONSIDERED

02/26/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.